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U.S. DEPARTMENT OF  
**ENERGY**

# Novel Magnetic Field Mapping Technology for Small and Closed Aperture Undulators

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**06.06.2017**

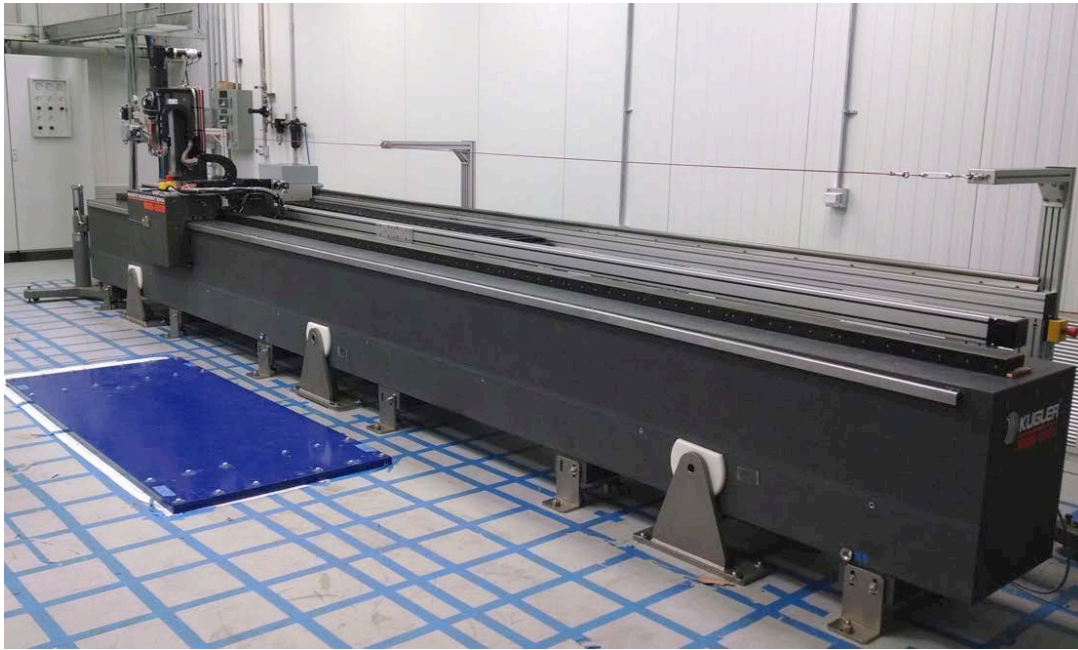
# Outline

- Introduction
  - Measurement systems at LBNL
  - Activities at LBNL
  - Need for new field mapping system
- System setup
  - Laser system
  - Compact sensor package
  - Sensor transport system
  - Control software
- Test measurement
  - Sensor calibration
  - Position measurement
  - Magnetic field measurement
- Summary

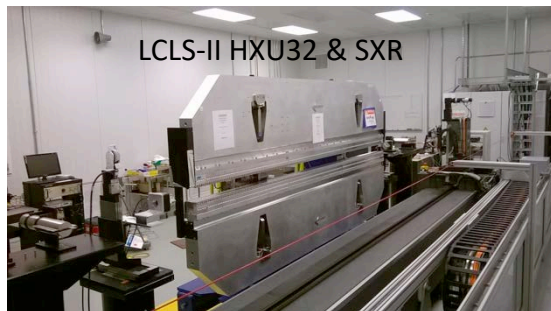
# Introduction

# UMF Undulator Measurement Facility

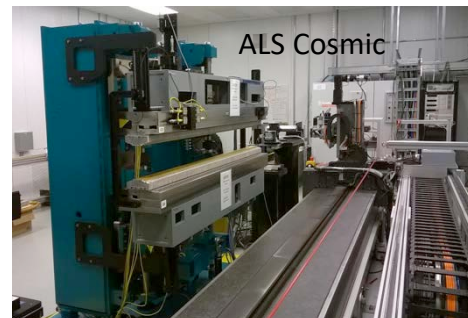
Temperature controlled ( $20 \pm 0.1^\circ \text{C}$ ) room with 1.2 m thick concrete floor.



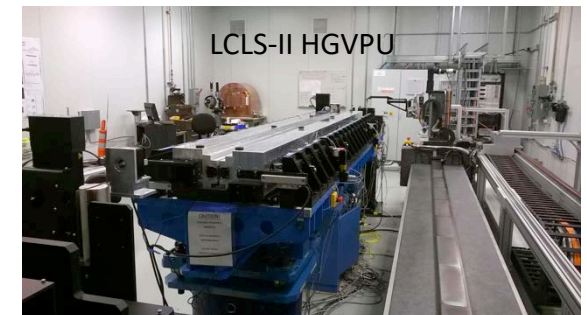
- 6.5 m long Hall probe bench
- Flip coil system at bench
- Automated measurements using batch scripts
- Mobile flip coil system
- Pulsed wire system
- Helmholtz coil system
- NMR probes
- Alignment magnets
- Rotating coils
- Small bore Hall probe system under development



LCLS-II HXU32 & SXR



ALS Cosmic



LCLS-II HGVPU

# Undulators for the LCLS-II

- Collaboration LBNL, ANL, and SLAC
- Extensive use of industrial suppliers



Small-Scale Prototype  
2013



Undulator Prototype ("HXU-32")  
2014



SXR Pre-Production  
2015

The HGVPUs were developed at ANL. LBNL has modified the magnet structure and arranged the production.



23 SXR undulators and 33 HGVPUs are in production.

23 HGVPUs will be tuned at LBNL.



# Cosmic EPU - assembled and tuned in house year 2016

## Main parameters

Period Length	38	mm
Gap	10	mm
Length	2106.39	mm
Number of full size poles	109	
Beam Energy	1.9	GeV

## Geometry

Width of magnets	30	mm
Height of magnets	25	mm
Thickness of magnets	9.35	mm
Coating thickness	6	$\mu\text{m}$
Gap between rows	1	mm

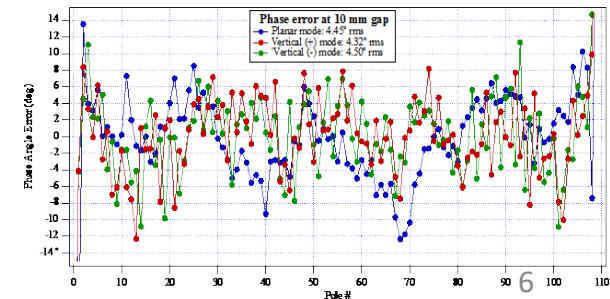
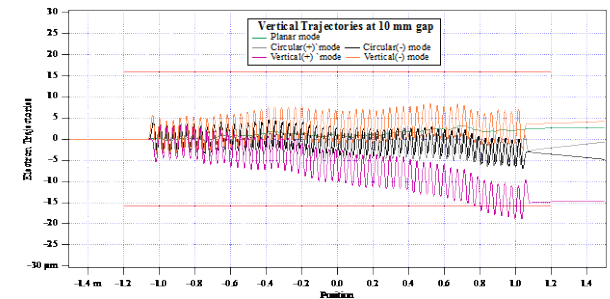
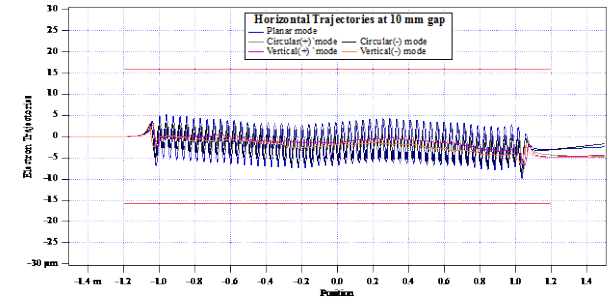
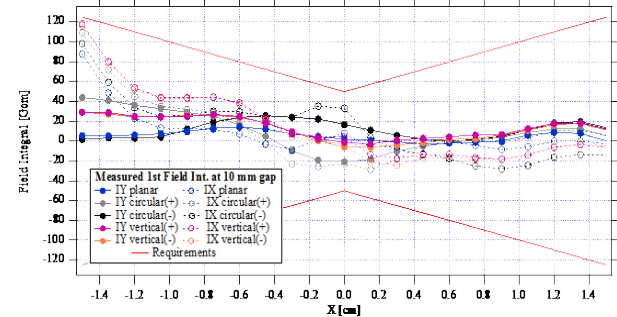
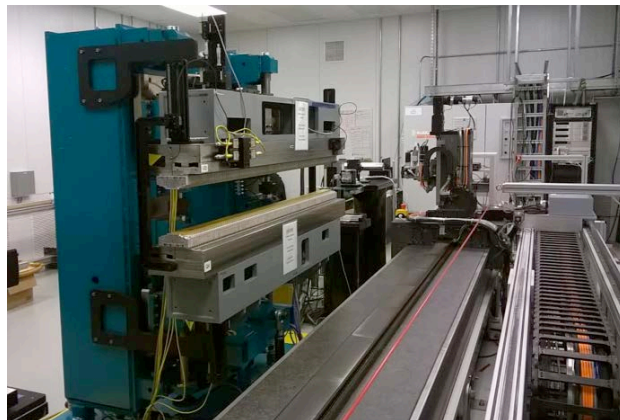
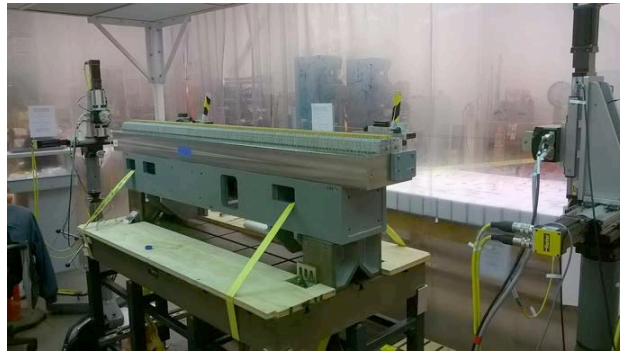
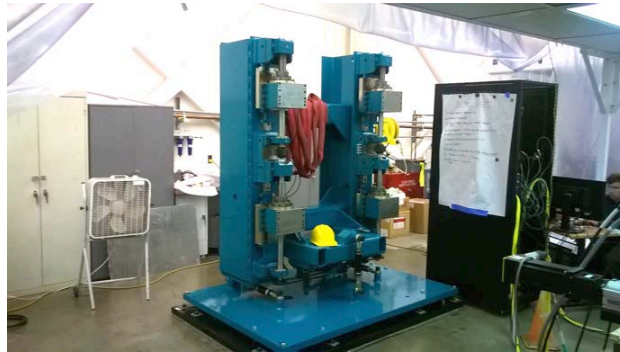
## Calculated

Mode	Phase [mm]	Effective vertical field [T]	Effective horizontal field [T]	K-value	Photon energy [eV]	Radiated power [kW]
Planar	0	0.896	0	3.18	149.1	1.93
Circular	11.236	0.535	0.535	2.69	195.7	1.38
Vertical	19	0	0.669	2.38	236.2	1.08
45° Incl	10.376	0.382	0.382	1.92	317.5	0.70

## Measured

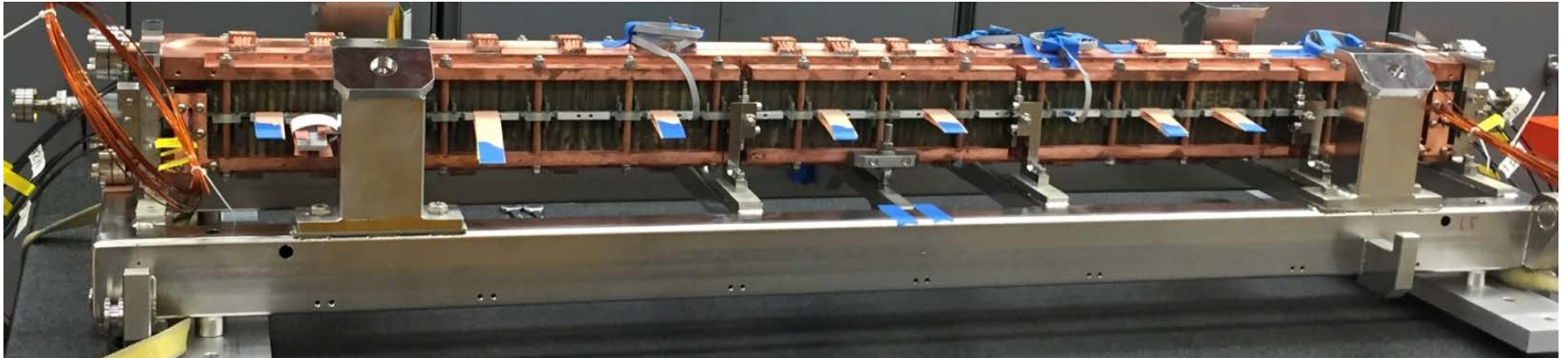
Gap mm	Mode	I1X Gcm	I1Y Gcm	I2X Gcm <sup>2</sup>	I2Y Gcm <sup>2</sup>	Ph.Er. °RMS	$B_{eff}$ T	Ph.En. eV
10	Planar	-4	14	-1753	-1523	4.45	0.892	150.0
10	Vertical (+)	-5	9	9206	-2772	4.32	0.669	236.4
10	Vertical (-)	-9	4	-2667	-2957	4.50	0.669	236.4
10	Circular (+)	-29	-13	410	-3127	0.759	0.759	194.8
10	Circular (-)	25	30	3022	-1067	0.754	0.754	196.8
10	Inclined (+)	39	4	6386	320	38.26	0.551	309.9
10	Inclined (-)	-36	21	-2161	-2784	6.32	0.552	308.9

Magnet blocks are mounted in pairs on keepers to minimize twisting of magnet blocks of during phase shifts.



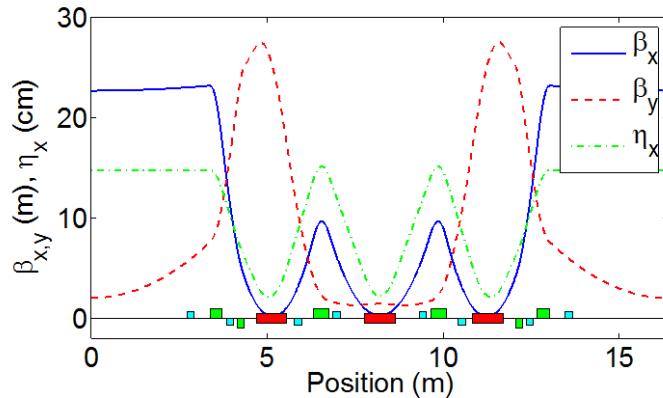
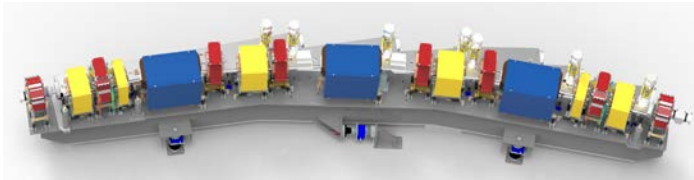
# Superconducting undulators using NbSn coils

- A 2015-2016 SLAC/ANL/LBNL collaboration with the following LBNL deliverables:
  - Fabrication of a 1.5 m long Nb<sub>3</sub>Sn undulator
  - Development and fabrication of field correction scheme
  - Development and transfer of pulsed wire setup for magnetic measurements (complementary to ANL measurement system)
- Final magnetic measurements performed in ANL cryostat

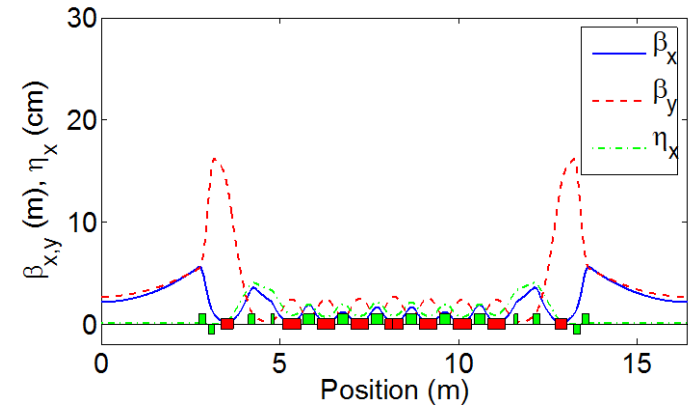
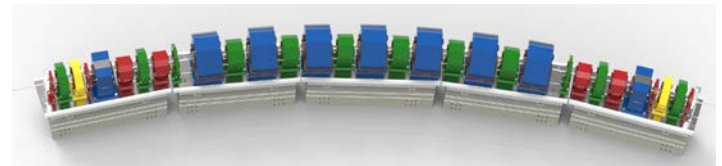


# ALS-U, upgrade of the ALS with a multi-bend achromat lattice reaches the soft x-ray diffraction limit up to 2 keV

ALS today : triple-bend achromat



ALS-U: multi-bend achromat



$$\varepsilon_x \approx \text{2000 pm-rad at } 1.9\text{GeV} \quad \varepsilon_x \approx \sigma_x \sigma_\theta \propto \frac{E^2}{N_D^3} \quad \varepsilon_x \sim \text{50 pm-rad at } 2.0\text{GeV}$$

**Large increase in coherent fraction due to lower emittance and smaller  $\beta$ -functions**

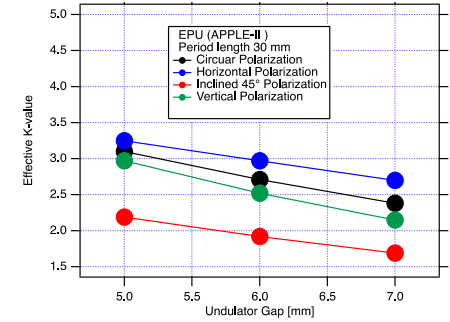
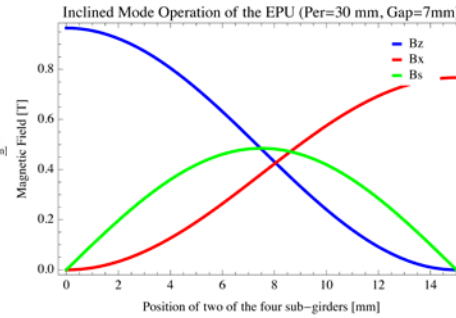
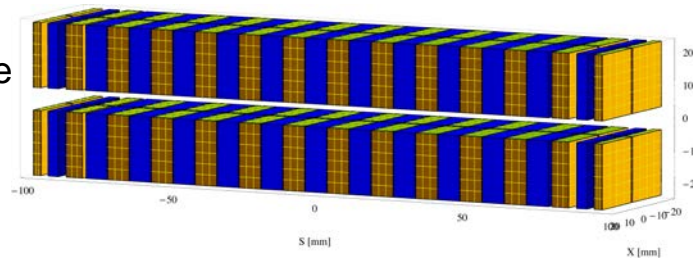
Insertion devices can have down to 4 mm diameter vacuum aperture



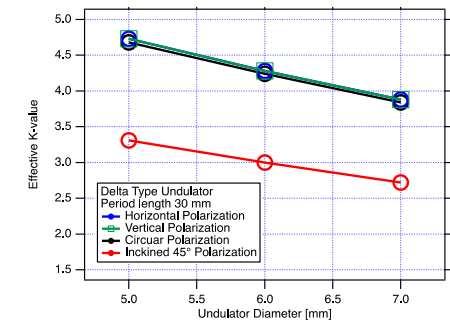
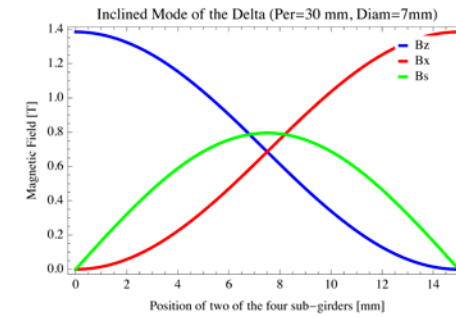
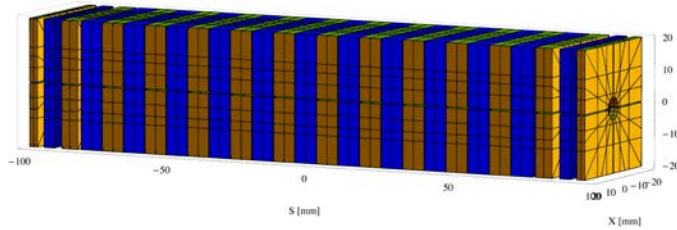
# Parameter studies for the ALS-U, examples

Radia is used for magnet calculations [O. Chubar, P. Elleaume and J. Chavanne, Journal of Synchrotron Radiation, 5:481-484, 1998.]

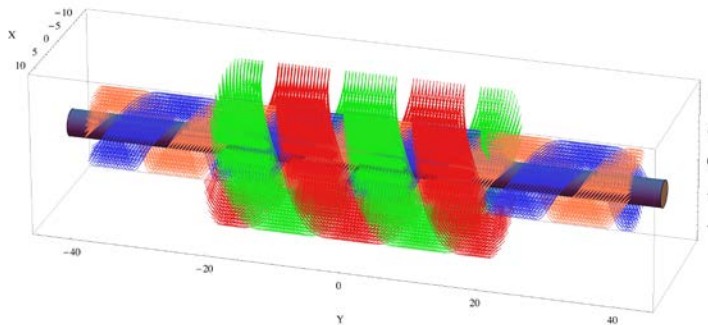
EPU of type APPLE-II



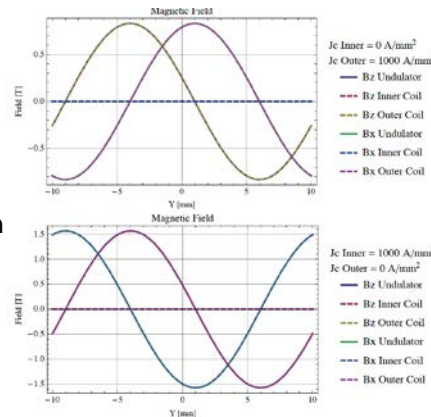
Delta type undulator



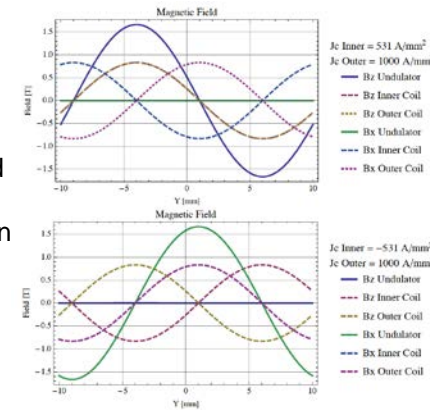
Superconducting double helical undulator



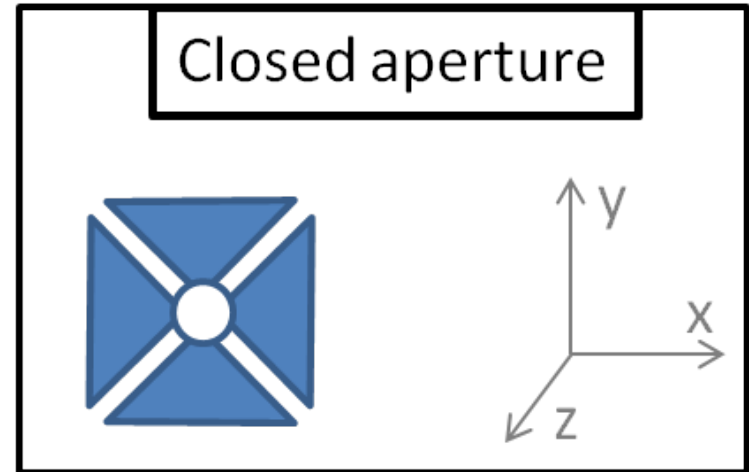
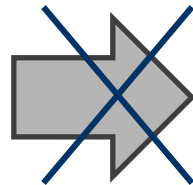
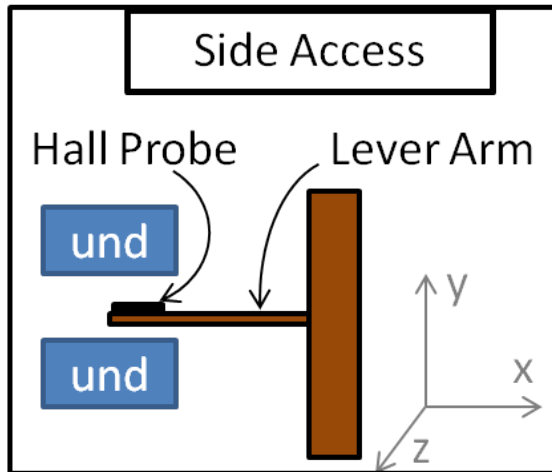
Circular right/left polarization



Planar and vertical polarization

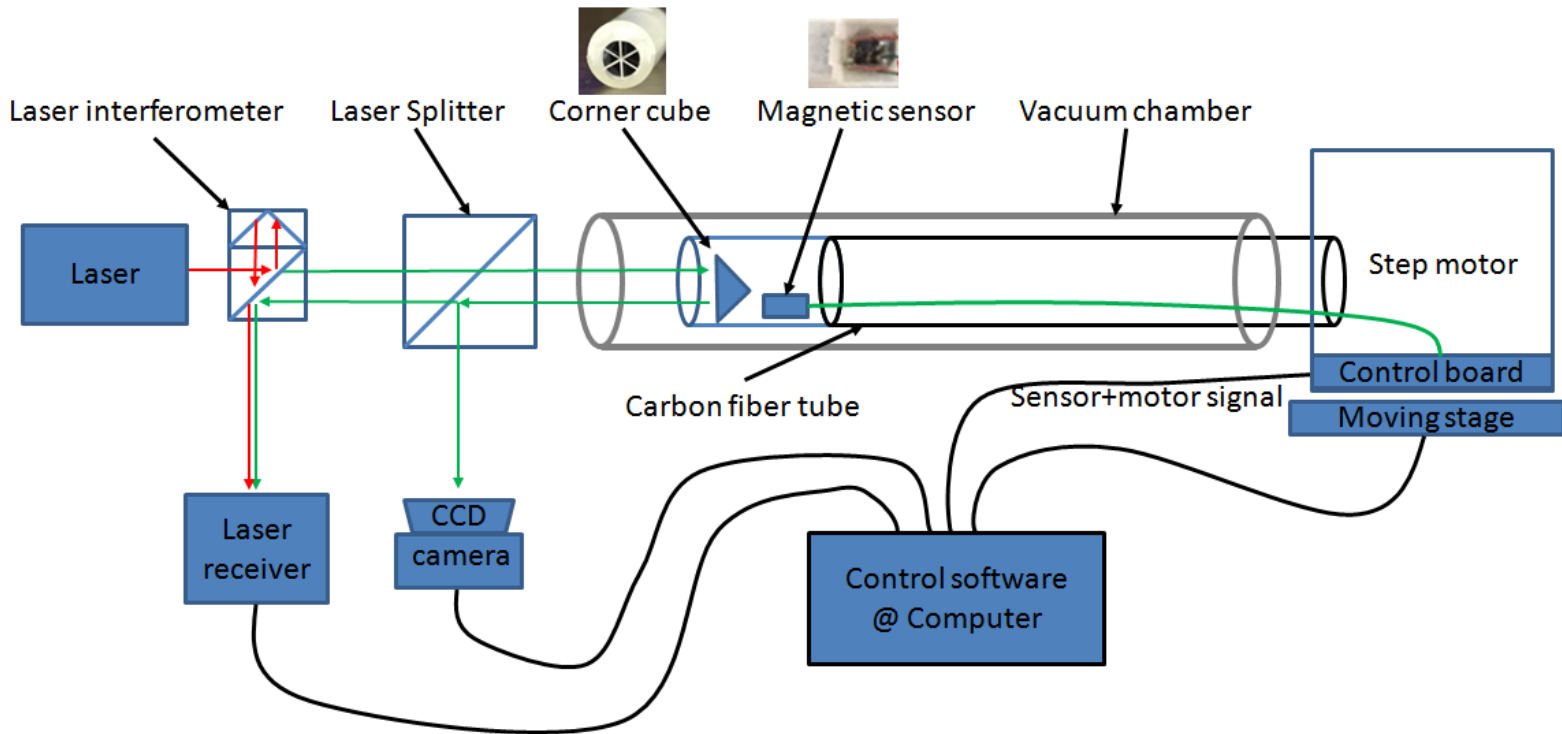


- Closed aperture insertion devices in the ALS-U and FELs
  - ~5 mm diameter vacuum chamber
  - Delta, Delta-X, and Superconducting bifilar helical undulators



- Need for field mapping in closed aperture undulators
  - LDRD funding for small bore measurement project obtained
  - First prototype is completed

- Concept for the closed aperture measurement system
  - Develop a novel ultra-compact magnetic field mapping sensor
  - 3D position measurement with laser interferometry and CCD camera
  - Rotation motion in transverse plane and longitudinal transportation
  - Allowing simultaneous position and magnetic measurement

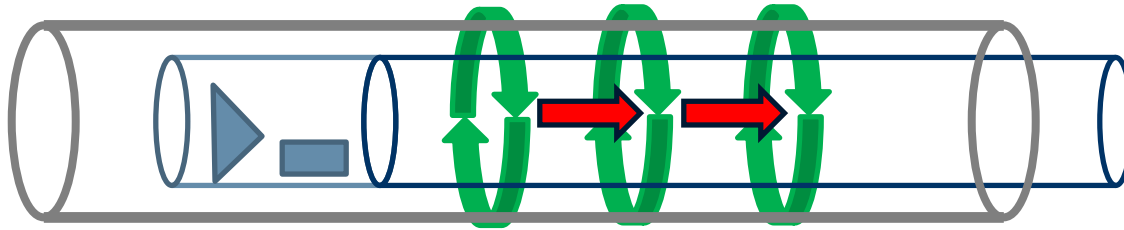


# Measurement concept

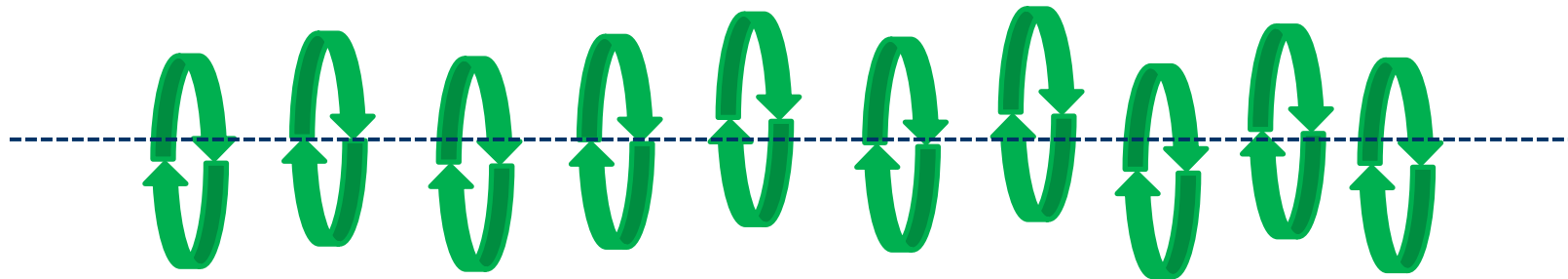
Measure the radial field on circles with radial hall probe

The position of the circle given by laser system

The complete field inside the circle is known



The circles will not be on a straight line since tube is not straight



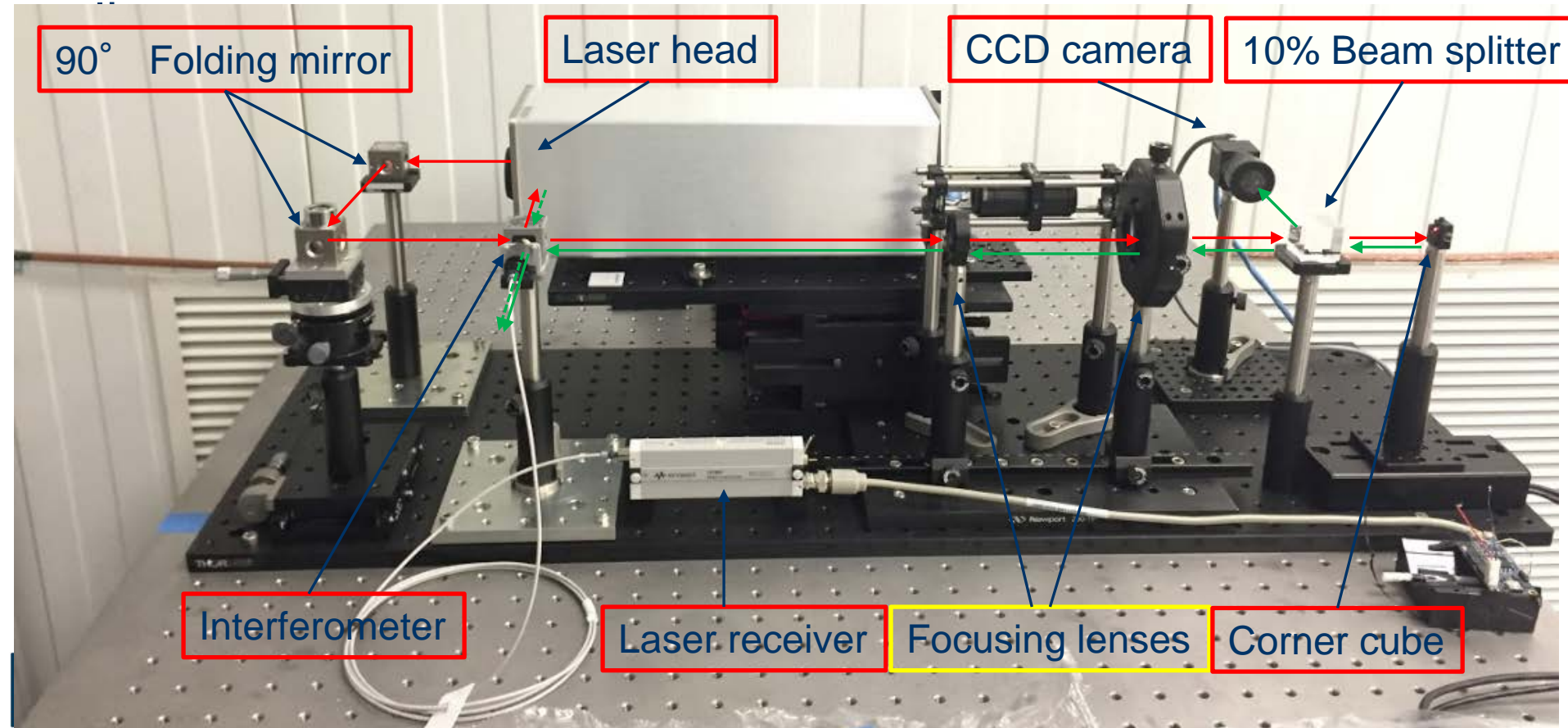
The field on the undulator axis is calculated from the circles



# System setup

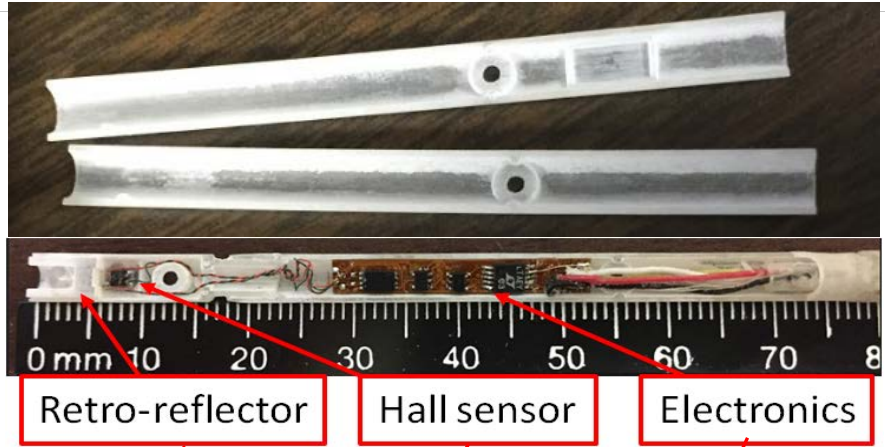
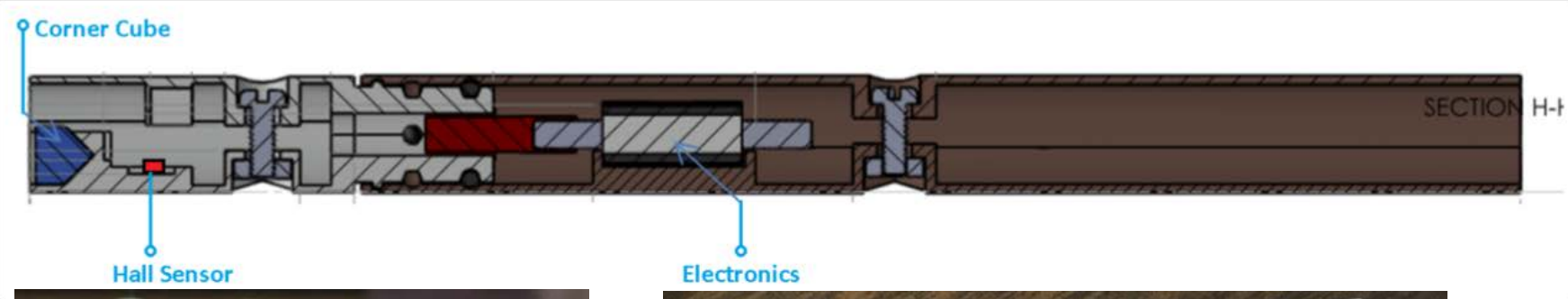
# Laser system

- Laser system set up
  - Put all parts on a single plate -> compact & easy to align



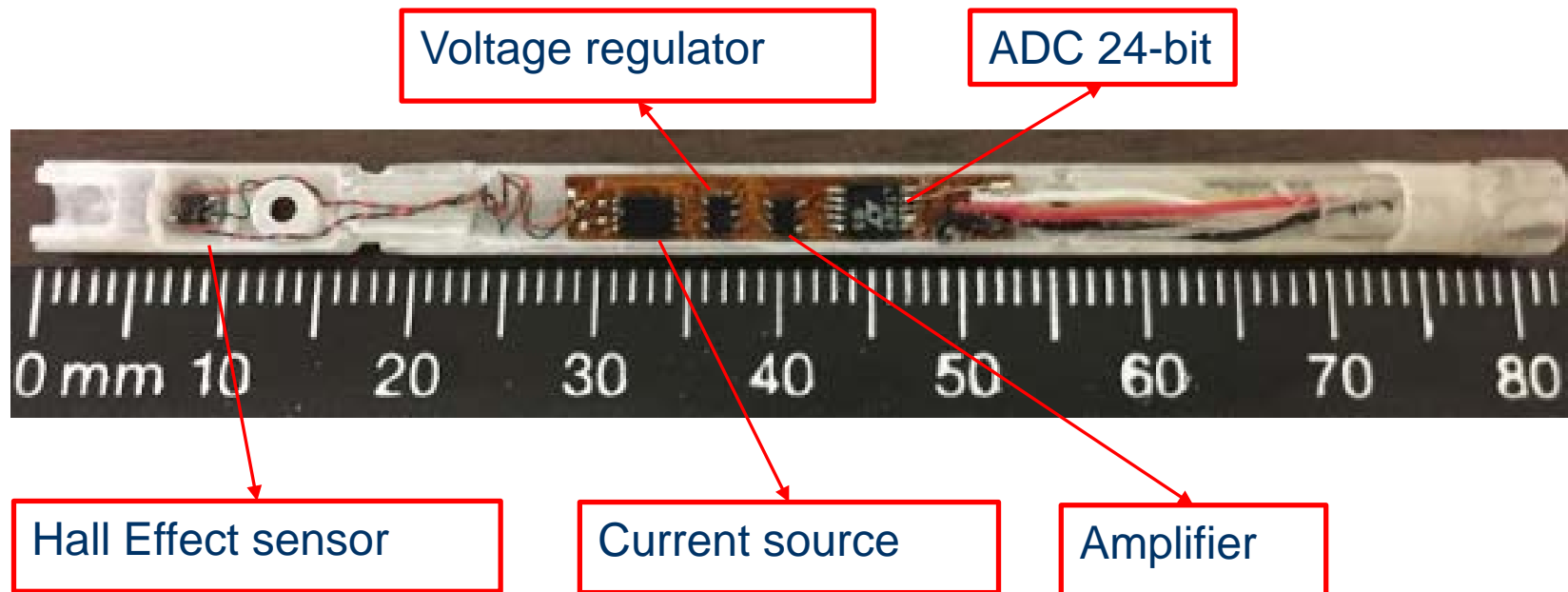
# Compact sensor package

- 3D printing parts & electronics



# Compact sensor package

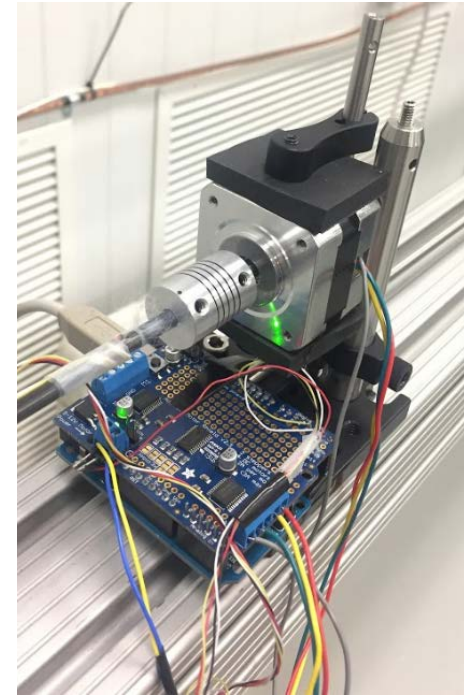
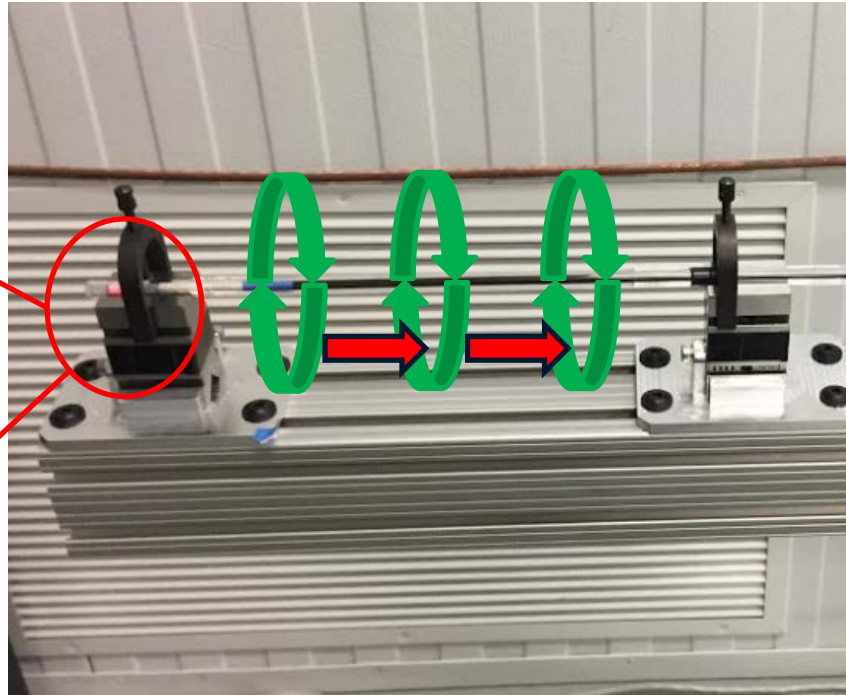
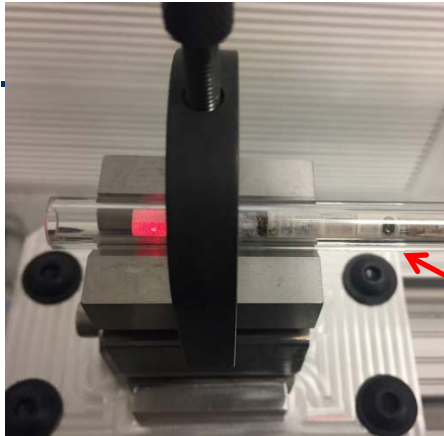
- 3D printing parts & electronics
  - Current source, Voltage regulator, Amplifier and ADC
  - High density interconnect flexible circuit





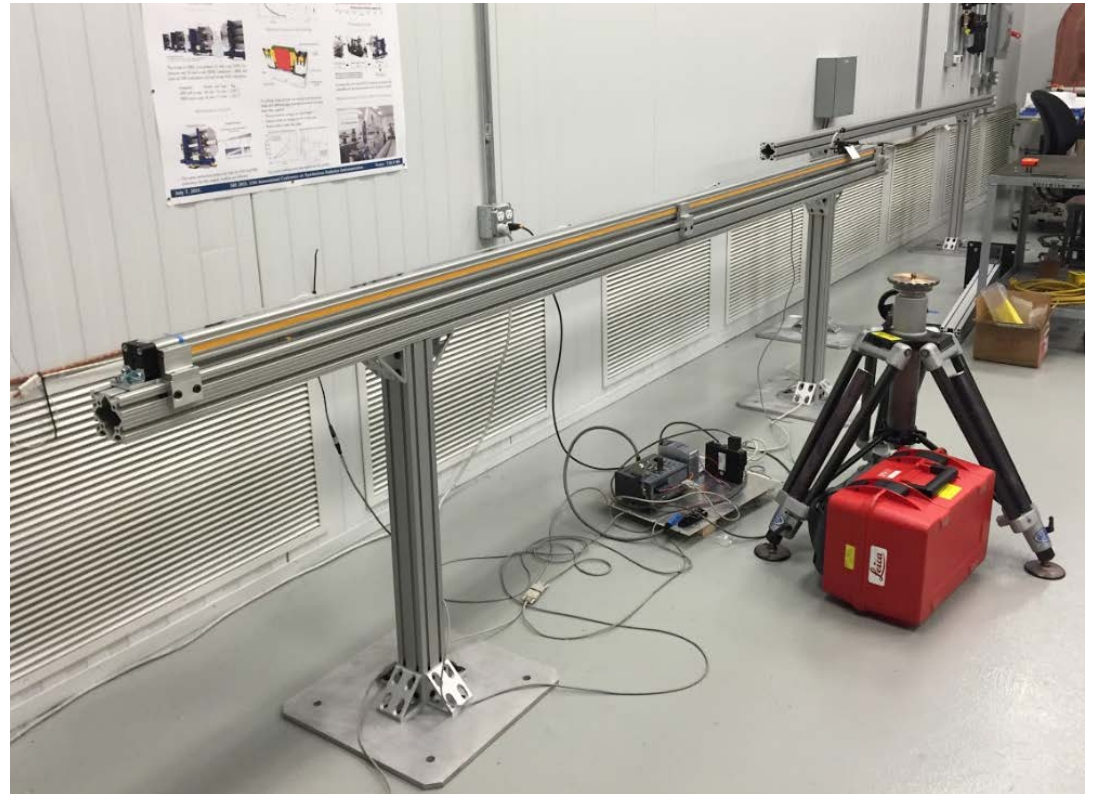
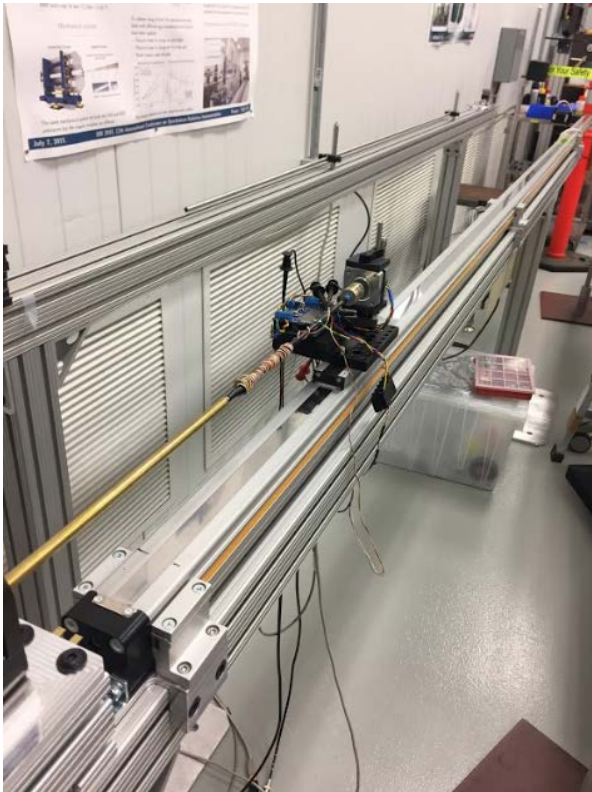
# Transport system

- Rotation motion by stepping motor gives Movement on a circle in transverse plane



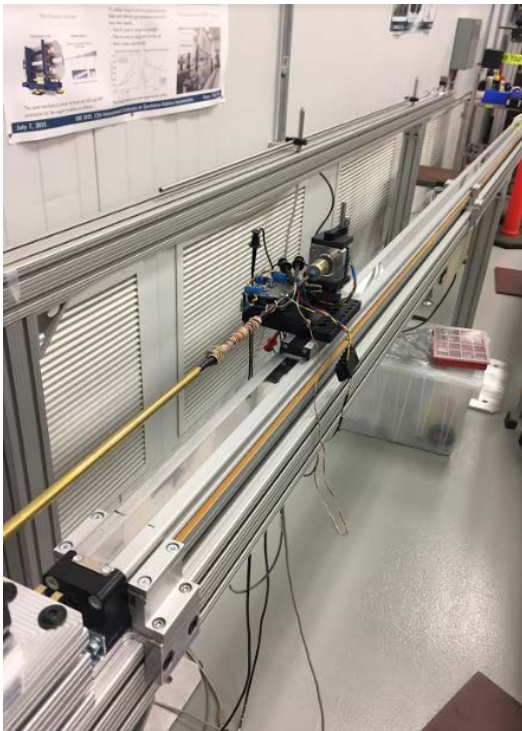
# Transport system

- Longitudinal movement by linear drive
  - Max. 3m movement along longitudinal direction



# Moving stage

- Control board and step motor

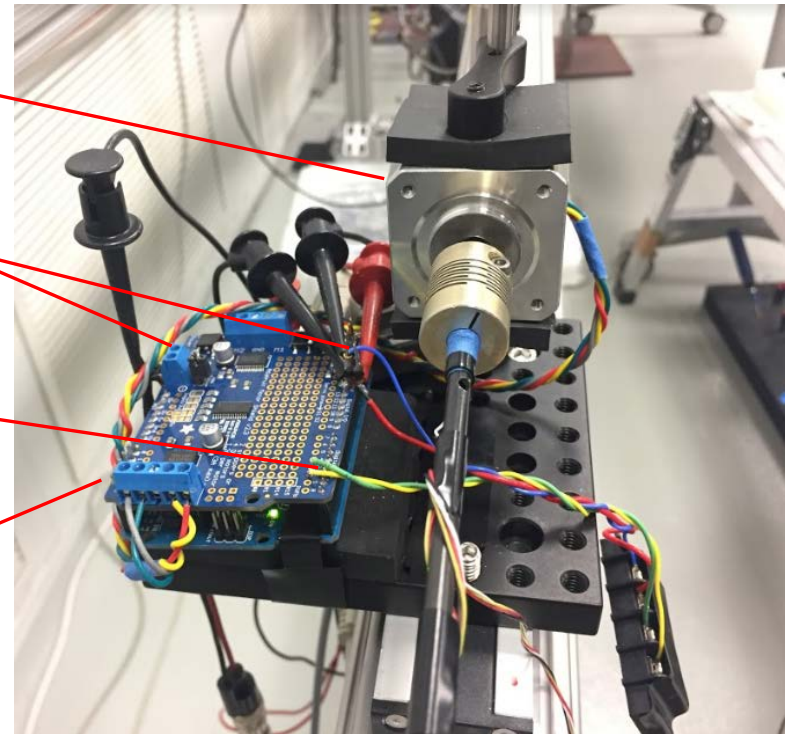


Step motor

Power input

Field signal

Control board



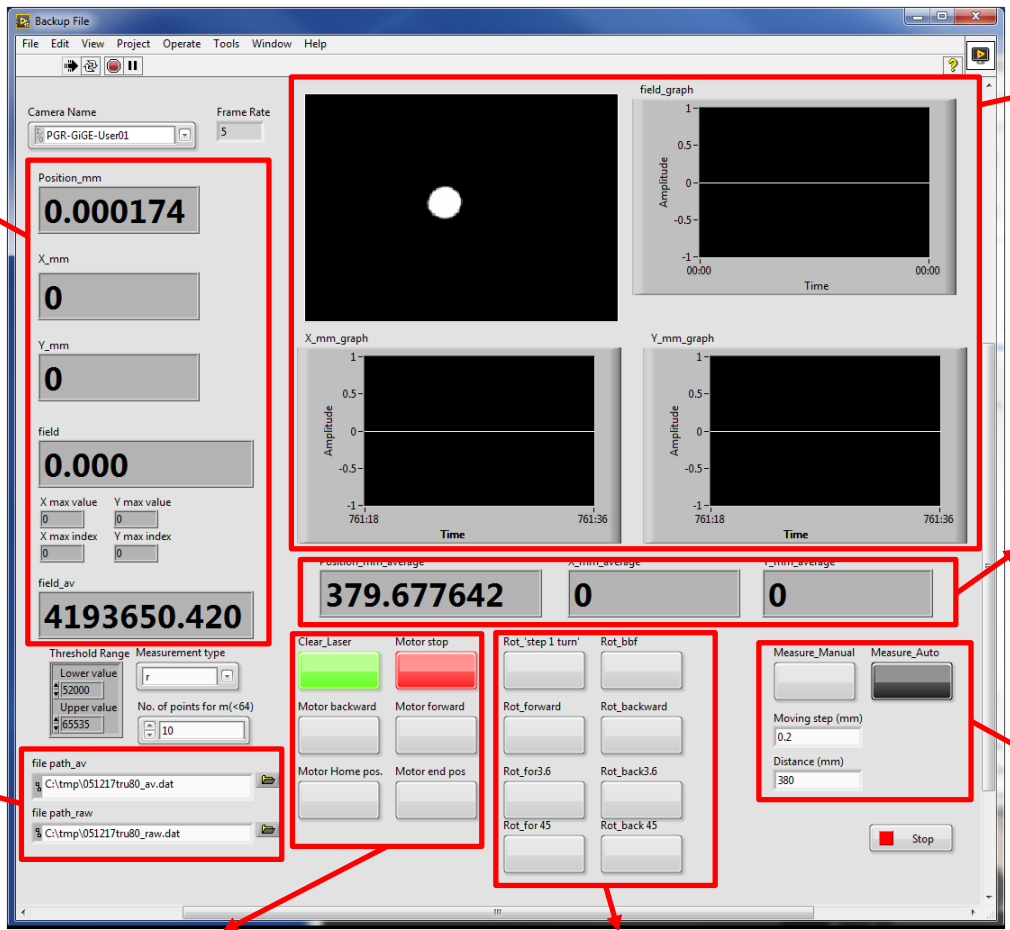


# Control software

- Control software made with Labview

Real time data  
Laser position  
& field

Laser position data  
& field data graph



Averaged data  
Laser position

Data logging  
file paths

Measurement  
control

Longitudinal motion control

Transverse rotation control

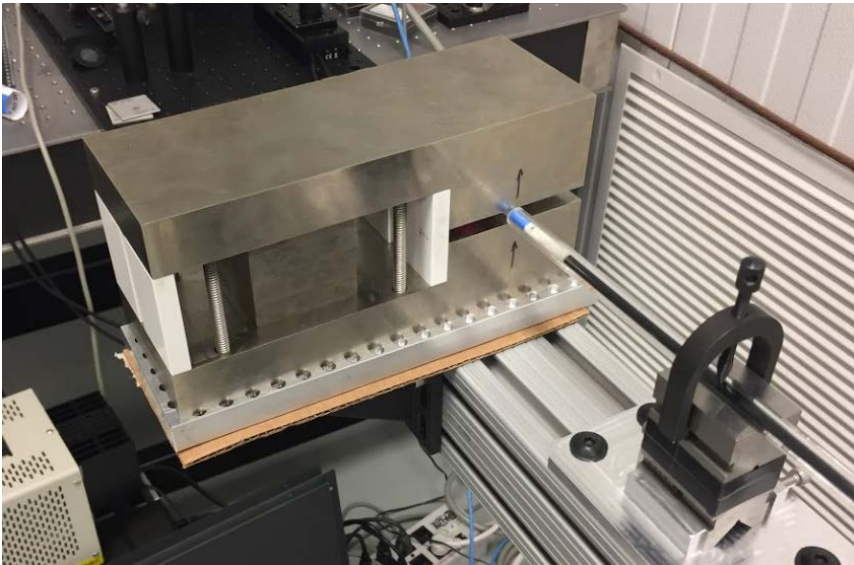




# Test measurement

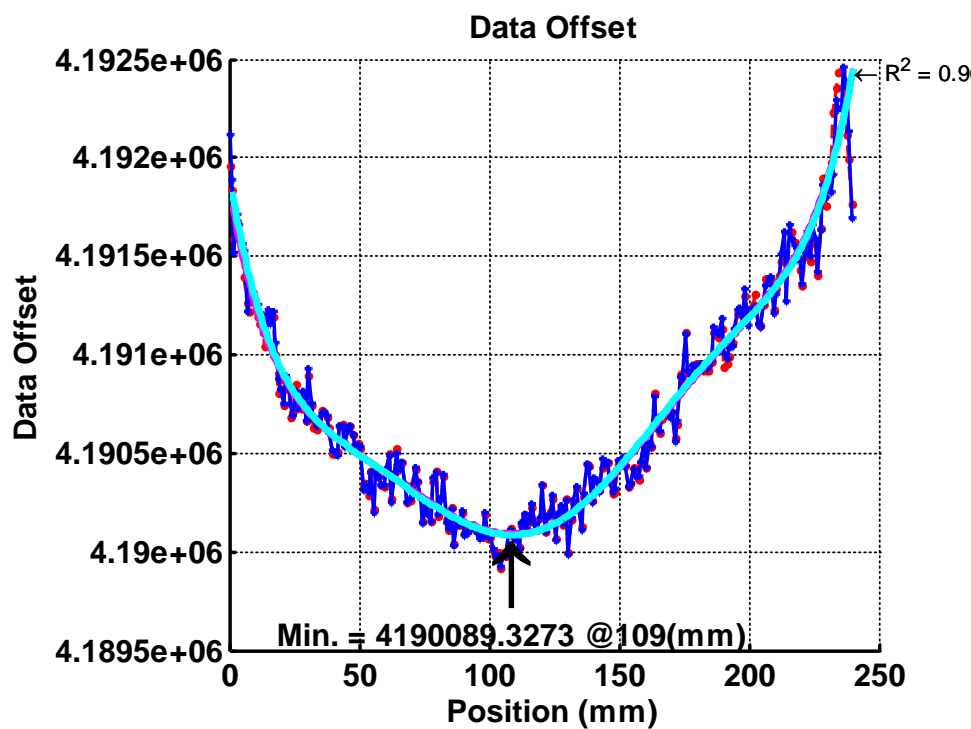
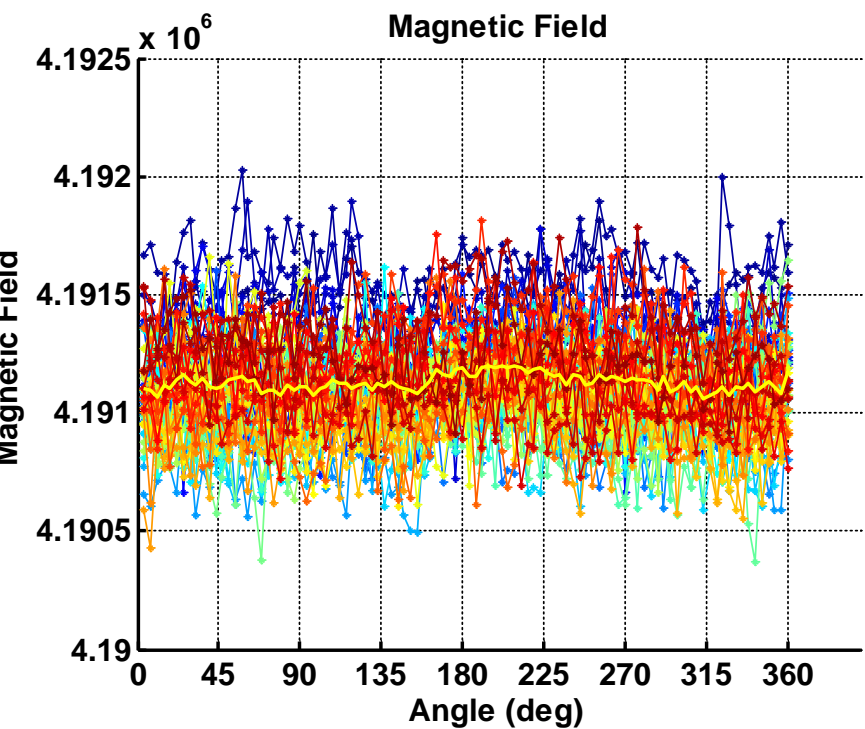
# Magnets for test

- Reference dipole magnet
  - Max. 0.2425 T @ gap center
  - For the sensor calibration
  - Noise level test
- 10 periods undulator
  - Max. 0.3958 T peak @ gap center
  - Measurement test



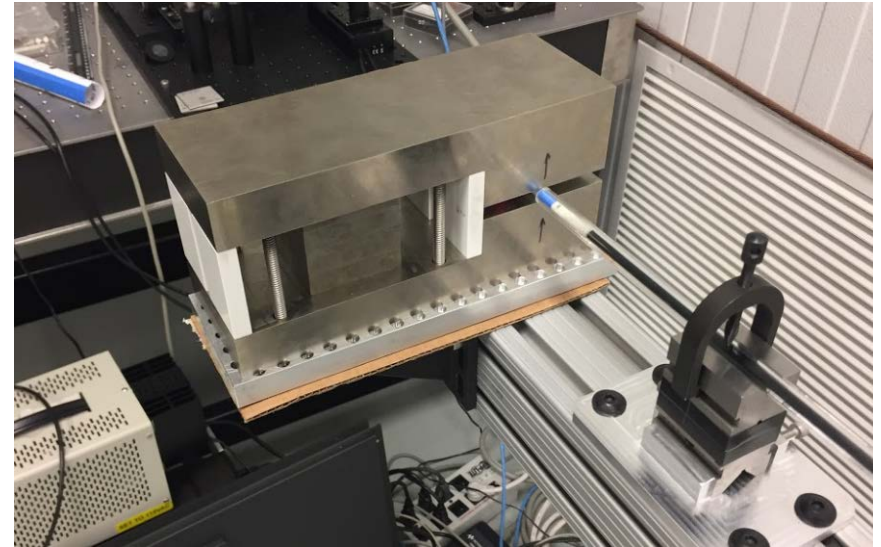
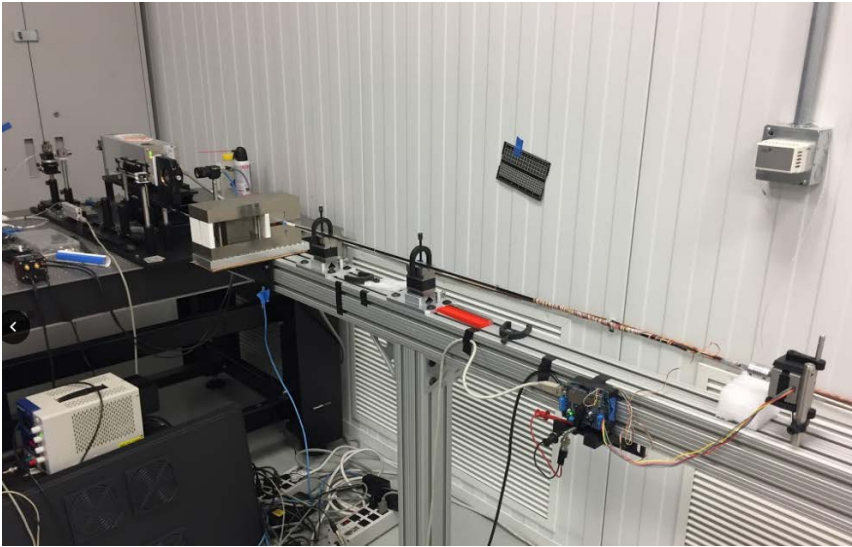
# Offset measurement in Zero Gauss Chamber

- Rotation measurement @ Z=120 mm in zero gauss cham
- Rotation measurement along z-axis in a zero gauss chamber



# Sensor Calibration

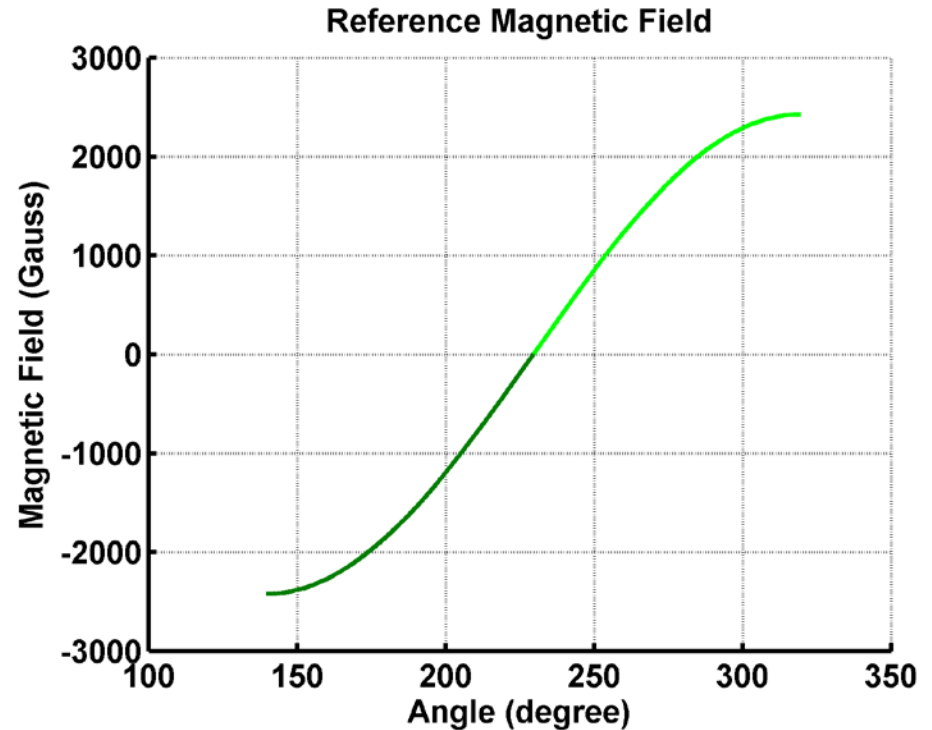
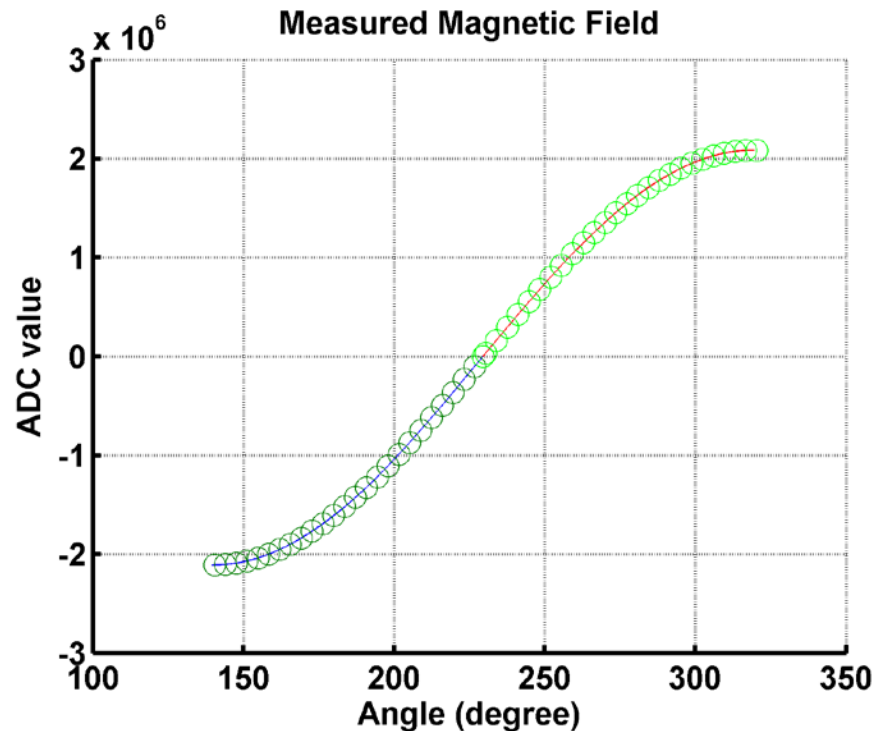
- Reference dipole magnet max. 0.2425 T
- Rotate sensor on central position of the magnet gap
- 200 point / turn (1.8 deg step), 100 turns averaged
- Using Linear polynomial curve fitting and extrapolation





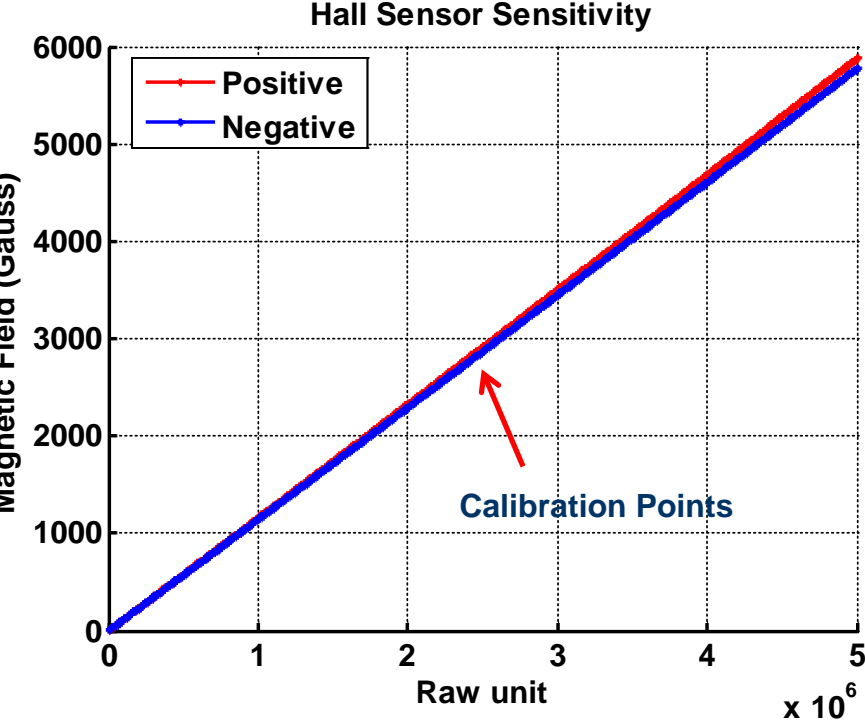
# Sensor Calibration

- Linear fitting with reference curve
  - Reference field : 0.2425 T peak sine curve
  - Set different sensitivity for negative and positive field



# Sensor Calibration

- Measured field sensitivity
  - Extrapolated after 0.2425 T for converting a stronger magnetic field



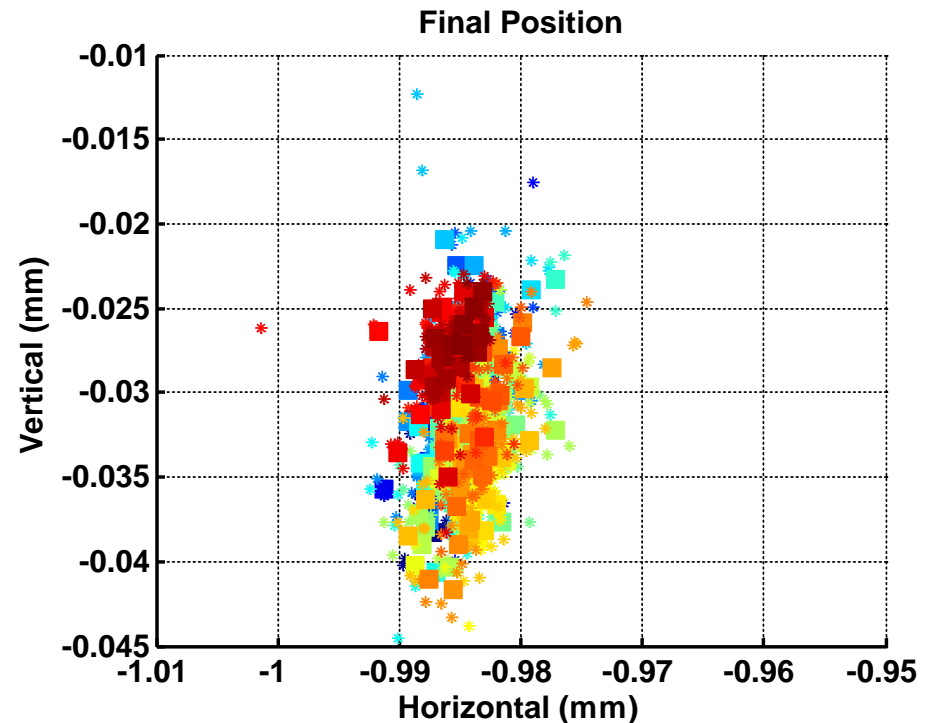
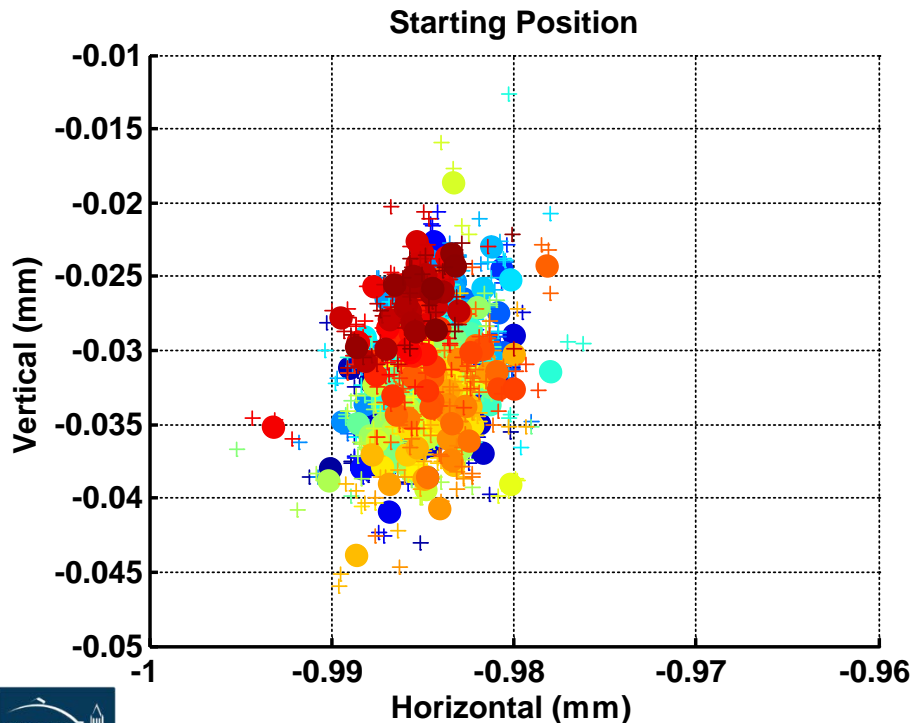
●電気的特性(測定温度 25°C) Electrical Characteristics(Ta=25°C)

項目 Item	記号 Symbol	測定条件 Conditions	最小 Min.	標準 Typ.	最大 Max.	単位 Unit
ホール出力電圧 Output Hall Voltage	$V_H$	B=50mT, $V_C=6V$	55		75	mV
入力抵抗 Input Resistance	$R_{in}$	B=0mT, $I_C=0.1mA$	650		850	$\Omega$
出力抵抗 Output Resistance	$R_{out}$	B=0mT, $I_C=0.1mA$	650		850	$\Omega$
不平衡電圧 Offset Voltage	$V_{OS}(V_O)$	B=0mT, $V_C=6V$	-11		+11	mV
出力電圧の温度係数 Temp. Coefficient of $V_H$	$\alpha V_H$	B=50mT, $I_C=5mA$ $T_a=25\sim 125^\circ C$			-0.06	%/ $^\circ C$
入力抵抗の温度係数 Temp. Coefficient of $R_{in}$	$\alpha R_{in}$	B=0mT, $I_C=0.1mA$ $T_a=25\sim 125^\circ C$			0.3	%/ $^\circ C$
ホール電圧直線性 Linearity	$\Delta K$	B=0.1/0.5T, $I_C=5mA$			2	%



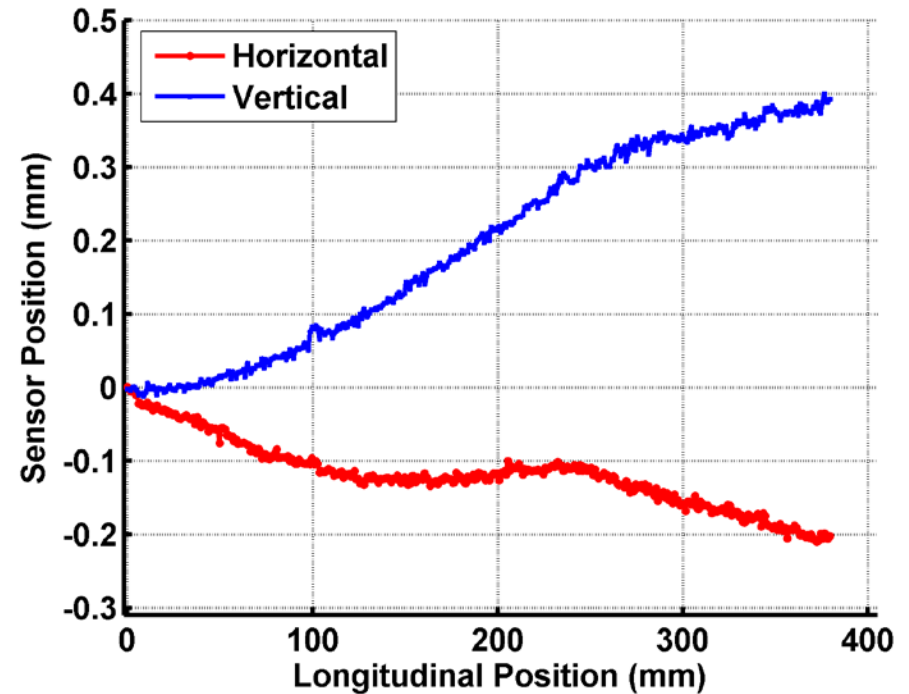
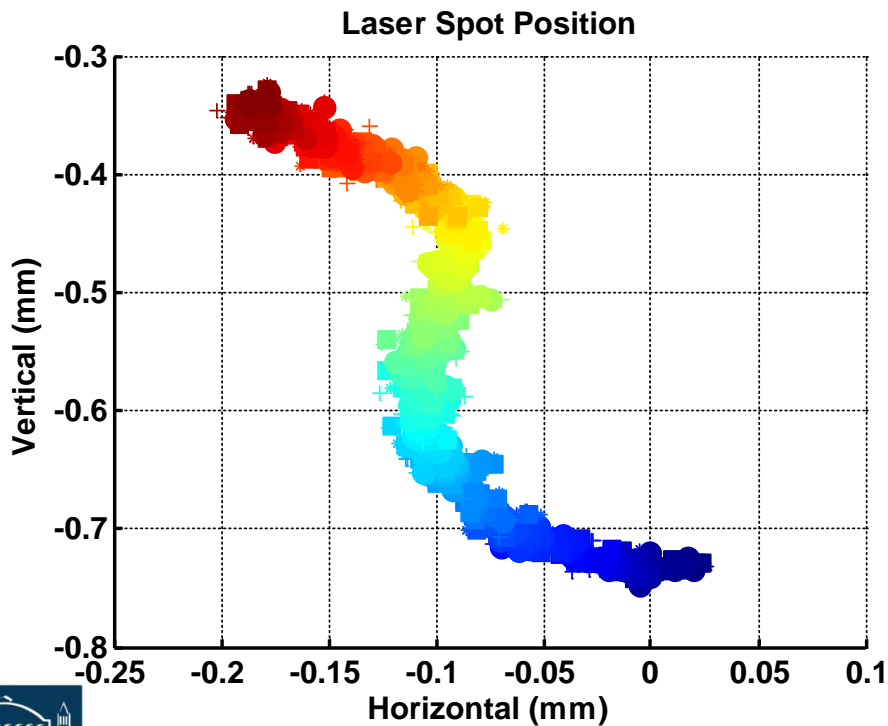
# Rotation motion test

- Track the starting and final position of laser spot
  - Compare start position and final position
  - All measured positions stay in  $\pm 15 \mu\text{m}$  range



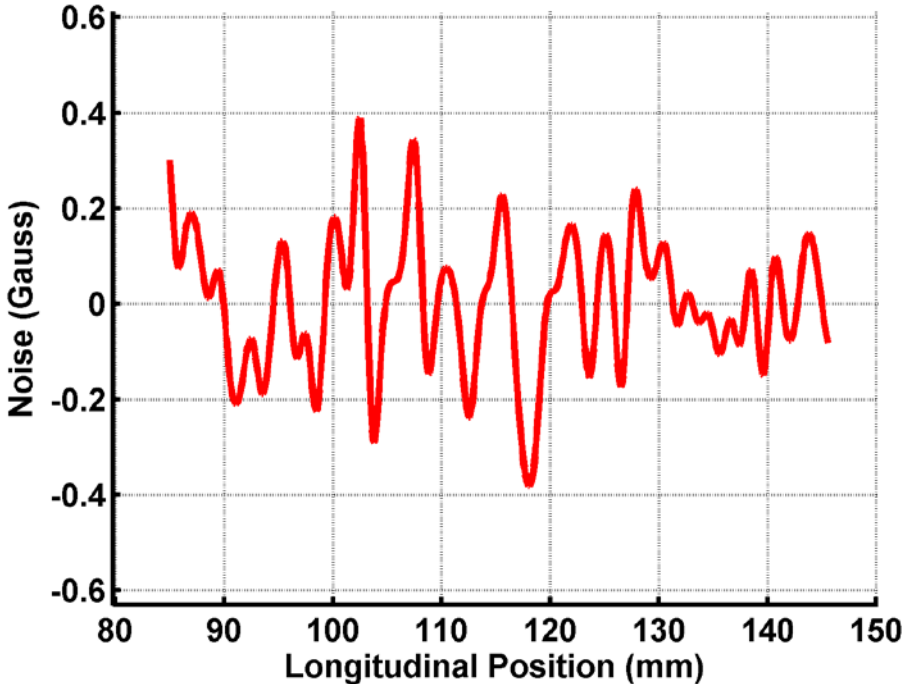
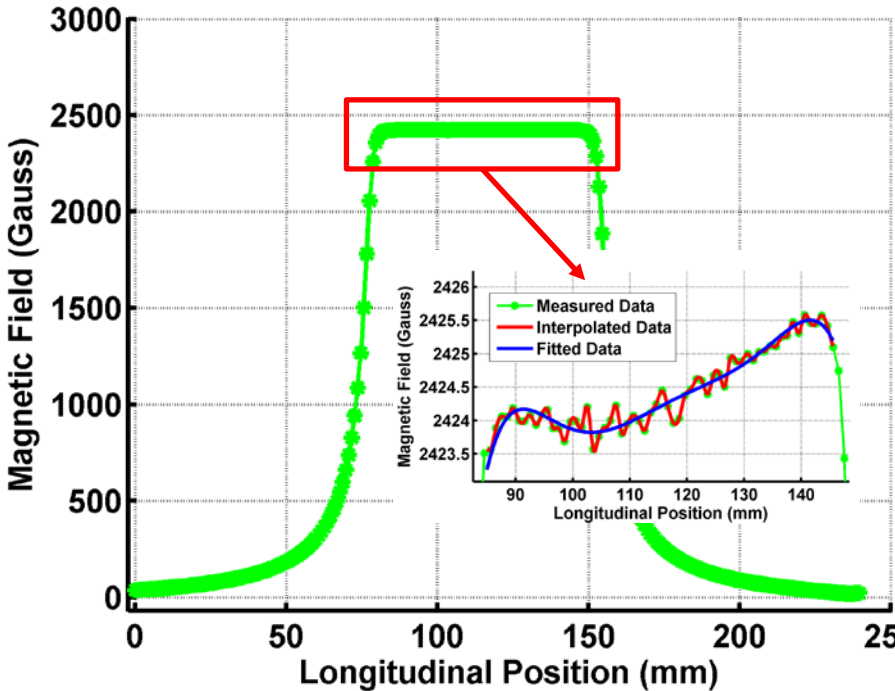
# Longitudinal motion test

- Track the laser spot along longitudinal position
  - Laser interferometry has submicron range resolution
  - 0 to 380 mm range measured for 10 periods undulator



# Magnetic field measurement

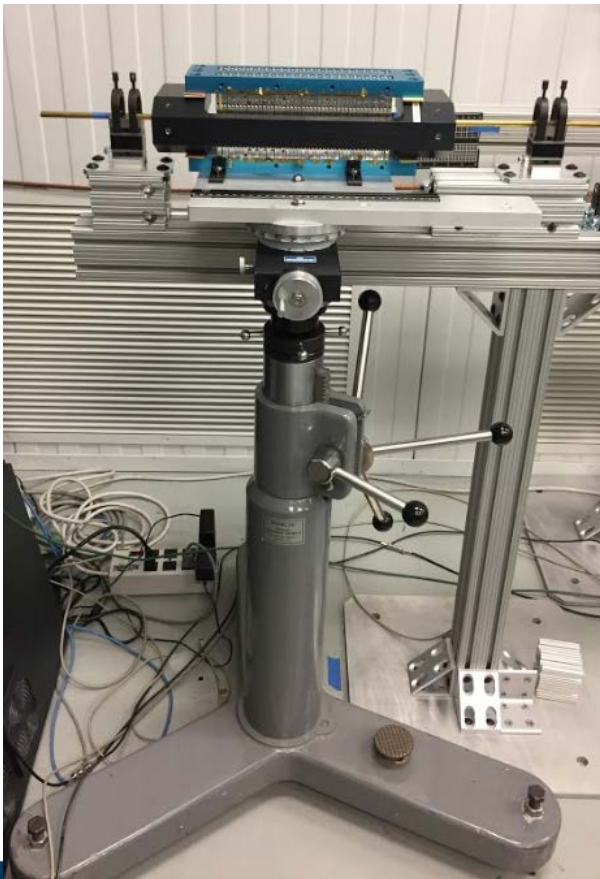
- Dipole magnet measurement result
  - Measurement result of the dipole magnet by scanning mode
  - Observed noise level of  $\pm 0.5$  G at a peak field region





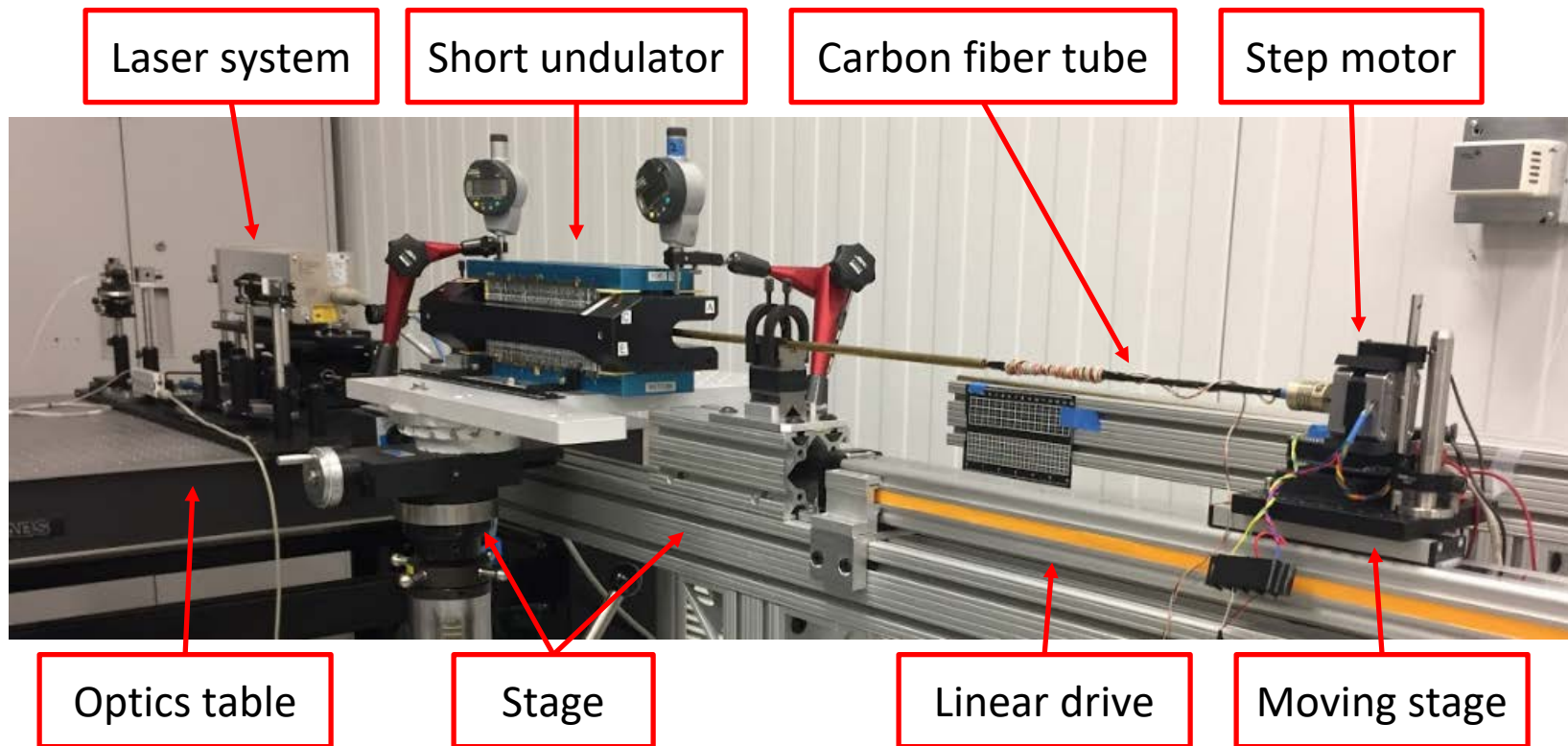
# Magnetic field measurement

- Setup - short undulator



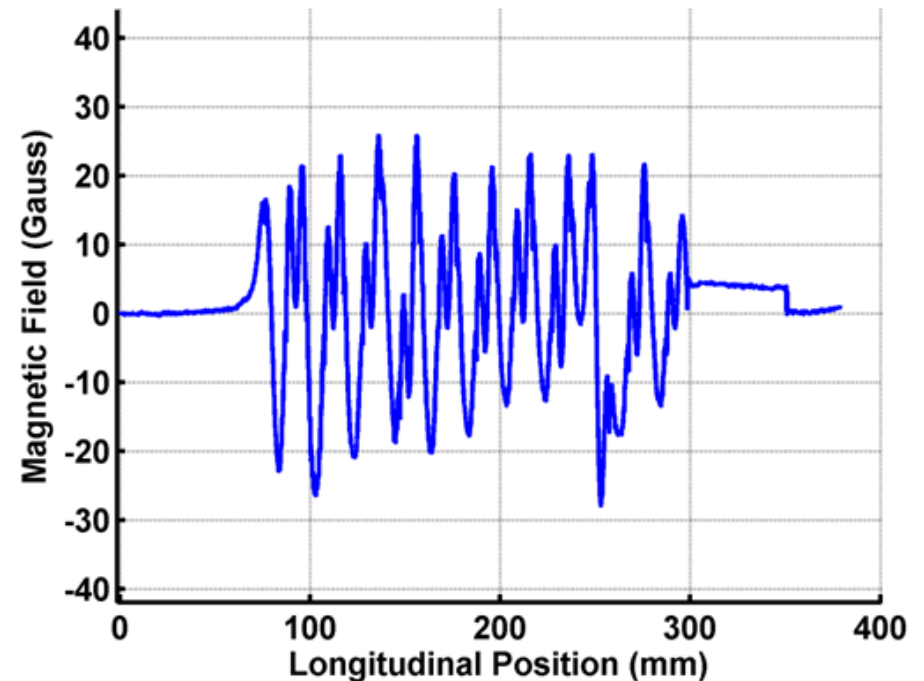
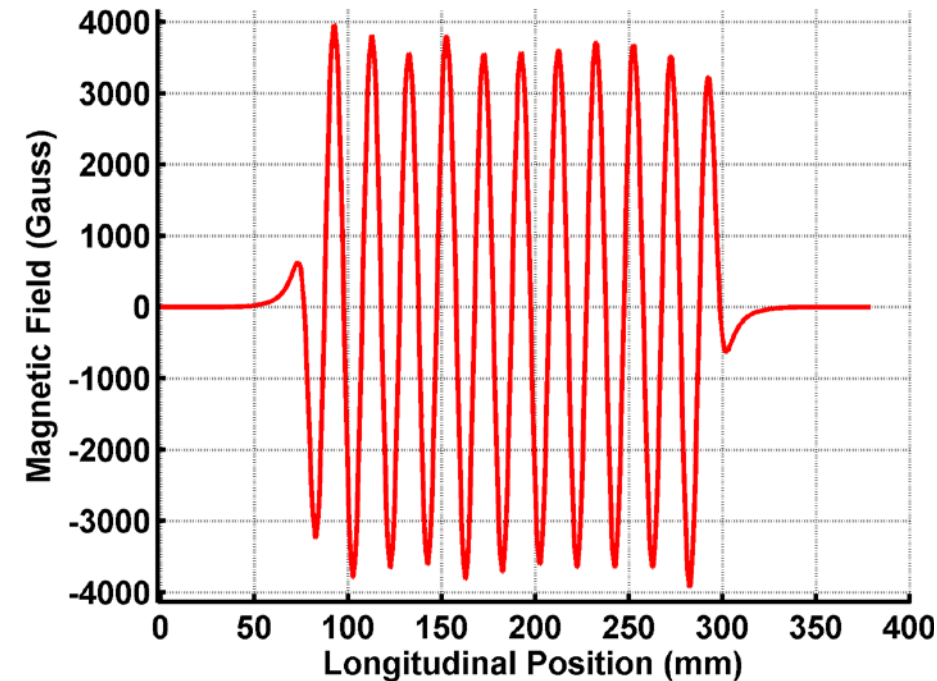
# Magnetic field measurement

- Setup - short undulator, complete system



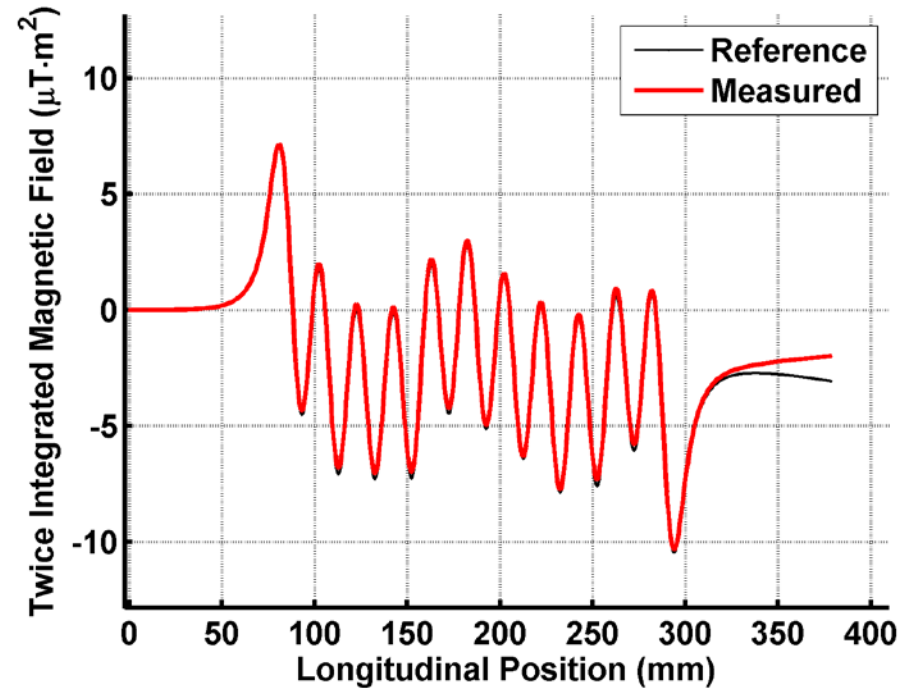
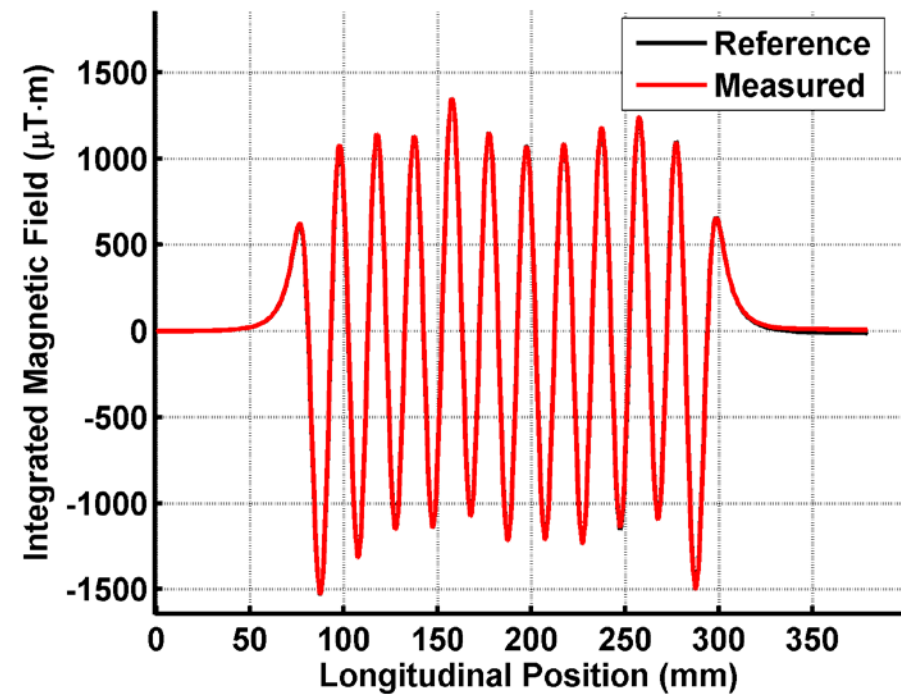
# Magnetic field measurement

- Undulator measurement result
  - Measurement result by scanning mode
  - Compared with reference measurement data



# Magnetic field measurement

- Undulator measurement result
  - Integrated and twice integrated magnetic field



# Summary

- A prototype of a magnetic measurement technique for closed aperture undulators has been developed
- An ultra-compact magnetic field sensor package and a 3D position acquisition system using a laser were combined with a magnetic sensor transport system
- Test measurements with a 0.2425 T dipole magnet and a short 10-period undulator were carried out
- Further improvements of the Hall probe sensor and 3D positioning system will be carried out
- The concept with measuring on circles gave valuable experience but will not be used in next generation of the closed aperture measurement system
- The closed aperture measurement system is a critical component for future work with novel undulators and the work will be continued.



# **Open Postdoctoral Position**

## **Lawrence Berkeley National Laboratory**



- **Magnetic field measurements on accelerator magnets and undulators**
- **Development of measurement methods and instrumentation**
- **Hardware development of sensors and electronics**
- **Development of laser interferometer systems for 3D positioning**

**If you are interested please contact Erik Wallén <[ejwallen@lbl.gov](mailto:ejwallen@lbl.gov)>**

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